



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Robert J. Small and Zhefei J. Chen
Title: Compositions for Chemical-Mechanical Planarization of Noble-Metal-Featured Substrates, Associated Methods, and Substrates Produced By Such Methods
Application No.: 10/057,206 Filing Date: January 25, 2002
Examiner: Michael Marcheschi Group Art Unit: 1755
Docket No.: CHEM.003US0 Conf. No.: 1702

Certificate of Transmission Under 37 CFR 1.8

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office on 10/9/03

Gulian Bower
Signature

COMMISSIONER FOR PATENTS

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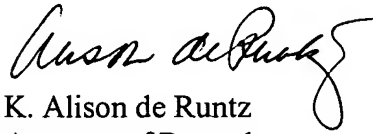
PETITION FOR EXTENSION OF TIME

Dear Sir:

Applicants respectfully petition for a three-month extension of time within which to respond to the April 29, 2003 outstanding Office Action, such extension allowing the undersigned until October 29, 2003 to respond.

A check is enclosed that includes the amount of \$950.00, as set forth in the enclosed transmittal letter.

Respectfully submitted,



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